

LASER INTERFEROMETER GRAVITATIONAL WAVE OBSERVATORY  
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CALIFORNIA INSTITUTE OF TECHNOLOGY  
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Technical Note	<b>LIGO-T1100595-v4-</b>	2014/03/26
<b>ETM/ITM Quad Suspension Control Ranges</b>		
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# 1 Introduction

This document defines the maximum range of the actuators on an Advanced LIGO (aLIGO) Quadruple (QUAD) suspension, used for input and end test masses (ITM and ETMs, respectively), given the final design of their respective signal chains. The range is calculated explicitly at DC in tabular form in section 3. Because the range depends on the actuator driver's frequency response which are different at each stage, the single actuator force as a function of frequency in section 4. The mechanical response to force longitudinal, pitch, and yaw are shown in 5. Finally, the magnitude of test mass displacement as a function of frequency for high(est)-range and low(set)-noise configurations is shown in section 6.

## 2 Calculating the Maximum Force

The maximum (peak) differential drive voltage,  $V_{max}$ , from an aLIGO Digital-to-Analog Converter (DAC), a General Standards PCIe66-18AO8, 18-bit, DAC card, is 10 [ $V_p$ ].

For the top three stages (TOP, UIM, and PUM), the force is calculated by multiplying the linear signal chain,

$$F = \eta T_{CD} G_{AI} V_{DAC} \quad (1)$$

where  $V_{DAC}$  is the applied DAC voltage,  $G_{AI}$  is the gain of the anti-aliasing chassis (assumed to be unity),  $T_{CD}$  is the transconductance of the coil driver (in [ $A/V$ ]), and  $\eta$  is the OSEM arrangement's coil-magnet force coefficient (in [ $N/A$ ]). Each isolation stage's driver circuit transconductance produces frequency-dependent current, and this frequency dependence is switchable such that the driver can meet both actuation range and output noise requirements. Table 1 summarizes the frequency response of each driver configuration for each stage. The assumed-frequency-independent, force-per-current coefficient for a given OSEM arrangement is then applied to determine the force produced in the actuator basis.

The test mass stage's, non-linear ESD's force is calculated as

$$F = \alpha (V_{bias} - V_{control})^2 \quad (2)$$

where  $\alpha$  is the non-linear force coefficient of the ESD pattern (in [ $N/V^2$ ]),  $V_{bias} = G_{ED}V_{DAC}$  (the product of the ESD driver voltage gain,  $G_{ED}$  and the applied DAC voltage) is the voltage on the bias pattern, and  $V_{control} = G_{ED}V_{DAC}$  is the voltage on the control pattern. The ESD driver, as currently designed, has a single, non-switchable pole at 2 [ $kHz$ ]. As higher bias voltage means a smaller degree of non-linearity, the bias voltage is always operated at the maximum possible voltage for a given ESD driver. If the control voltage were equal, but opposite in sign, we could achieve a maximum force of

$$|F_{max}^{(ESD)}| = 4\alpha(G_{ED}V_{max})^2. \quad (3)$$

However, the ESD is inherently attractive and we wish to have both attractive and repulsive forces. We have therefore assumed that the control voltage is operated with a force offset of half the maximum possible, leaving the operational maximum force to be

$$|F_{op.\ max}^{(ESD)}| = 2\alpha(G_{ED}V_{max})^2. \quad (4)$$

For all stages, the frequency-dependent, single-actuator, maximum force is converted to the Euler basis using the number of actuators and lever arm for each degree of freedom, which is then propagated through the aLIGO production QUAD matlab model transfer functions between each stage's degree of freedom excitation and test mass displacement in the same degree of freedom.

Table 1: Frequency response for each state of the three upper-stage QUAD actuator driver types. Maximum range states are marked with  $\dagger$ , low-noise states are marked with  $\diamond$ .

Driver	Drawing #	State Name	(zeros):(poles) [Hz]
TOP	D0902747-v4	acq $\dagger$	(31):(0.9)
		lp $\diamond$	(10, 31):(0.9, 1)
UIM	D070481-v4	acq $\dagger$	(50):(300)
		lp1	(10.5, 50):(1, 300)
		lp2	(10.5, 10.5, 50):(1, 1, 300)
		lp3 $\diamond$	(10.5, 10.5, 10.5, 50):(1, 1, 1, 300)
MODUIM	T1400223-v1	acq $\dagger$	(85):(300)
		lp1	(10.5, 85):(1, 300)
		lp2	(10.5, 10.5, 85):(1, 1, 300)
		lp3 $\diamond$	(10.5, 10.5, 10.5, 85):(1, 1, 1, 300)
PUM	D070483-v5	acqOff lpOff	(12):(110)
		acqOn lpOff $\dagger$	(1.35):(80.5)
		acqOff lpOn $\diamond$	(6, 12, 20):(0.5, 110, 250)
		acqOn lpOn	(1.35, 6, 20):(0.5, 80.5, 250)

Table 2: Configurations of the test-mass stage electro-static drive.

Driver	Driver Drawing #	State Name	Driver Gain [V/V]	Gap Size [mm]	Pattern Type
ESD	T1000220-v1	acq5mm $\dagger$	40	5.0	ETM (D0900949-v2)
		ln5mm $\diamond$	1.1	5.0	ETM (D0900949-v2)
		acq20mm $\dagger$	40	20.0	ITM (D080177-v4)
		ln20mm $\diamond$	1.1	20.0	ITM (D080177-v4)

### 3 Maximum Displacement at DC

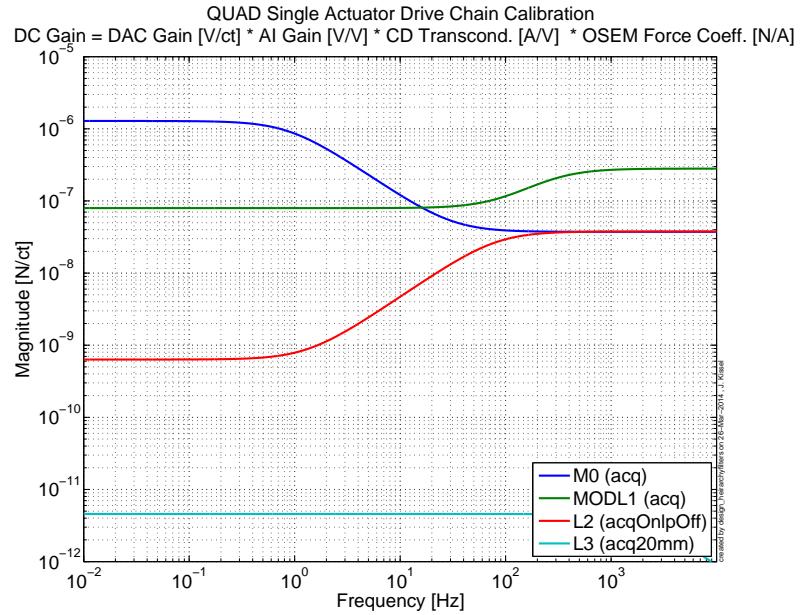
# LIGO-T1100595-v4

ETM/ITM Quad Suspension Detailed OSEMS, Magnets, ESDs and DC control ranges at each stage T1100595-v4 Norma A Robertson and Jeff Kissel 26th May 2014							
<b>Max DAC Voltage</b> [V p] (Differential voltage across the Plus and Minus legs)							
10							
<b>Units</b>							
<b>Suspension Stage</b> [l] <b>OSEM Type</b> [l] <b>Magnet Type</b> [mm] <b>Magnet Size diameter x thickness</b> [N/A] <b>Coil Magnet Actuation Strength</b> [N/mA]							
Main and Reaction Chain Top (TOP) BOSEM NdFeB 10 x 10 1.694 0.001694							
Upper-Intermediate Mass (UIM) BOSEM SmCo 10 x 10 1.694 0.001694							
PenUltimate Mass (PUM) AOSEM SmCo 2 x 6 0.0309 0.0000309							
<b>Units</b> [mA/V] <b>DC Transconductance</b> [mA_p] <b>DC Max Current Output</b> [mA_pp] <b>DC Current Range</b> [(mA_A_pp) or (mA_A_rms)] <b>DC Current Range Requirement</b> [Hz]							
TOP (D0902747-v4) 9.943 99.43 198.86 200 (pp) continuous							
UIM (D070481-v4) 0.1535 1.535 3.07 2 (rms) < 1							
MODUIM (T1400223-v1) 0.6154 6.154 12.308 2 (rms) < 1							
PUM (D070483-v5) 0.2685 2.685 5.37 16 (rms) 200 - 5000							
<b>Units</b> [Degree of Freedom (DOF)] <b>Stage</b> [l] <b>DC Compliance at Mass</b> [(m/N) or (rad/N.m)] <b>Lever Arm</b> [m] <b># of OSEMs</b> [l] <b>DC Compliance at Coil Driver Output</b> [(m/mA) or (rad/mA)]							
Longitudinal TOP 0.000348 1 2 1.179E-06 1.172E-04 117.23 2.345E-04 234.461							
Pitch TOP 0.033500 0.078 1 4.426E-06 4.401E-04 440.12 8.802E-04 880.238							
Yaw TOP 0.015100 0.12 2 6.139E-06 6.104E-04 610.41 1.221E-03 1220.813							
Longitudinal UIM 0.000630 1 4 4.269E-06 6.553E-06 6.55 1.311E-05 13.105							
Pitch UIM 0.047200 0.065 4 2.079E-05 3.191E-05 31.91 6.382E-05 63.822							
Yaw UIM 0.036500 0.065 4 1.608E-05 2.468E-05 24.68 4.935E-05 49.354							
Longitudinal MODUIM 0.000630 1 4 4.269E-06 2.627E-05 26.27 5.254E-05 52.541							
Pitch MODUIM 0.047200 0.065 4 2.079E-05 1.279E-04 127.93 2.559E-04 255.866							
Yaw MODUIM 0.036500 0.065 4 1.608E-05 9.893E-05 98.93 1.979E-04 197.864							
Longitudinal PUM 0.001060 1 4 1.310E-07 3.518E-07 0.35 7.036E-07 0.704							
Pitch PUM 0.078600 0.0707 4 6.868E-07 1.844E-06 1.84 3.688E-06 3.688							
Yaw PUM 0.053500 0.0707 4 4.675E-07 1.255E-06 1.26 2.511E-06 2.511							
<b>ESD Driver</b> [V/V] <b>DC Gain (Differential In to Single-ended Out)</b> [V p] <b>DC Max Voltage Output</b> [V pp] <b>DC Voltage Range</b> [V pp] <b>DC Voltage Range Requirement</b> [Hz]							
Acquisition Driver (T1000220-v1) 40 400 800 800 < 2000							
Low Noise Driver (T0900567, see above) 1.1 11 22 30 < 2000							
<b>ESD Pattern / Driver</b> [mm] <b>RM to TST Gap Size</b> [N/V^2] <b>Actuation Strength (all four quadrants)</b> [V p] <b>Max BIAS Voltage</b> [V p] <b>Max QUAD Voltage</b> [V p] <b>Max Force</b> [N p] <b>Max Force w/ Bias Offset ***</b> [N p]							
ETM / Acquire 5 4.20E-10 400 400 2.69E-04 1.34E-04							
ITM / Acquire 20 7.50E-12 400 400 4.80E-06 2.40E-06							
ETM / Low Noise 5 4.20E-10 11 11 2.03E-07 1.02E-07							
ITM / Low Noise 20 7.50E-12 11 11 3.63E-09 1.82E-09 *** In order to get both attractive and repulsive forces, we'll operate with a force offset of -1/2 Fmax, see reference P1000032 below							
<b>Degree of Freedom (DOF)</b> [l] <b>Stage / Driver</b> [l] <b>DC Compliance at Mass</b> [(m/N) or (rad/N.m)] <b>Lever Arm</b> [m] <b>DC Max Disp. from ESD w/ Force Offset</b> [(m_p) or (rad_p)] <b>DC Max Disp. from ESD w/ Force Offset</b> [(m_p) or (rad_p)] <b>DC Disp Range from ESD w/ Force Offset</b> [(m_pp) or (rad_pp)] <b>DC Disp. Range from ESD w/ Force Offset</b> [(m_pp) or (rad_pp)]							
Longitudinal ETM / Acq. 0.0026 1 3.494E-07 349.440 6.989E-07 698.880							
Pitch ETM / Acq. 0.116 0.14 2.183E-06 2182.656 4.365E-06 4365.312							
Yaw ETM / Acq. 0.105 0.14 1.976E-06 1975.680 3.951E-06 3951.360							
Longitudinal ITM / Acq. 0.0026 1 6.240E-09 6.240 1.248E-08 12.480							
Pitch ITM / Acq. 0.116 0.15 4.176E-08 41.760 8.352E-08 83.520							
Yaw ITM / Acq. 0.105 0.15 3.780E-08 37.800 7.560E-08 75.600							
Longitudinal ETM / Low Noise 0.0026 1 2.643E-10 0.264 5.285E-10 0.529							
Pitch ETM / Low Noise 0.116 0.14 1.651E-09 1.651 3.301E-09 3.301							
Yaw ETM / Low Noise 0.105 0.14 1.494E-09 1.494 2.988E-09 2.988							
Longitudinal ITM / Low Noise 0.0026 1 4.719E-12 0.005 9.438E-12 0.009							
Pitch ITM / Low Noise 0.116 0.15 3.158E-11 0.032 6.316E-11 0.063							
Yaw ITM / Low Noise 0.105 0.15 2.859E-11 0.029 5.717E-11 0.057							
<b>References</b>							
DAC Voltage T1200311-v1							
OSEM and Magnet details M000034-v4							
OSEM Coil/Magnet Actuation Strengths T1000164-v3							
DC Compliances for long/pitch/yaw <a href="https://regut.ligo-wa.caltech.edu/svn/sus/trunk/Common/SusModelTags/MatLab/quadmodelproduction_rev3111_fiber_2012-09-06.mat">https://regut.ligo-wa.caltech.edu/svn/sus/trunk/Common/SusModelTags/MatLab/quadmodelproduction_rev3111_fiber_2012-09-06.mat</a>							
Coil driver requirements T1000097-v1							
Informed by <a href="http://www.lsc.caltech.edu/~ana/alIGO/uselecreq.html">http://www.lsc.caltech.edu/~ana/alIGO/uselecreq.html</a>							
Coil Driver DC Transconductance T1400223							
Lever Arms D0901346 for TOP, UIM, and PUM drives; D0900949 / D080177 for ETM / ITM ESD Patterns (assumes that effective lever arm for ESD is in the middle [radially] of the pattern)							
Actuation strength for ESD drive T1000119-v1, Figure 4, 20[mm] gap, Nominal pattern for ITM, G0900956-v1, pg 7 for ETM							
Peak Voltage for Low Noise ESD Driver T1300479, Section 5							
Maximum Force Used (with -1/2 Fmax offset) P1000032-v3, Section 5.3.1.3, pg 251 (or 291 of the .pdf)							

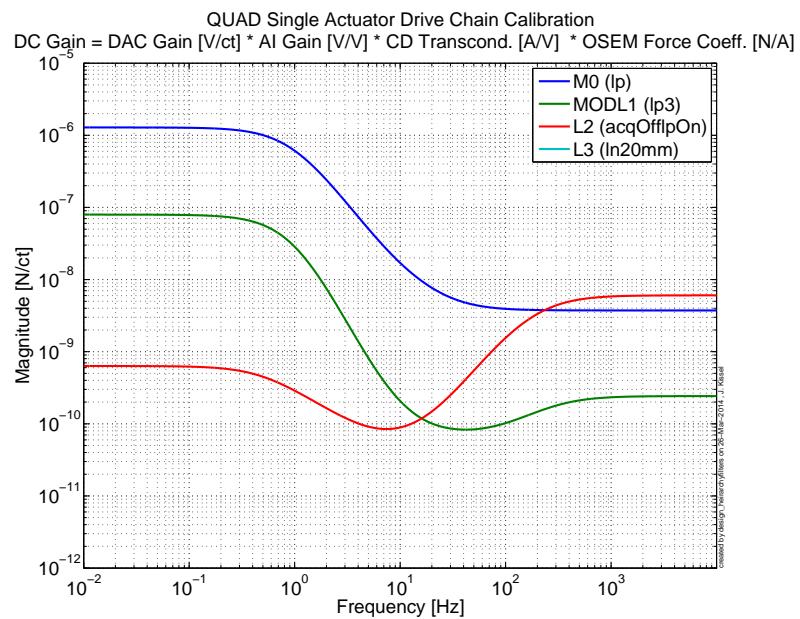
Figure 1: Explicit actuation range calculation at DC for aLIGO QUAD Suspension. As this calculation is prone to erroneous factors of two everywhere (differential vs. single ended, peak vs. peak-to-peak, etc.), the calculation is shown explicitly from both the maximum displacement (peak) and displacement range (peak-to-peak). Note that maximum, peak values are denoted with subscript “p,” and range, peak-to-peak values are denoted with subscript “pp.” Similar results from -v1 of this document should be compared against the peak-to-peak range.

## 4 Single-Actuator Actuation Strength

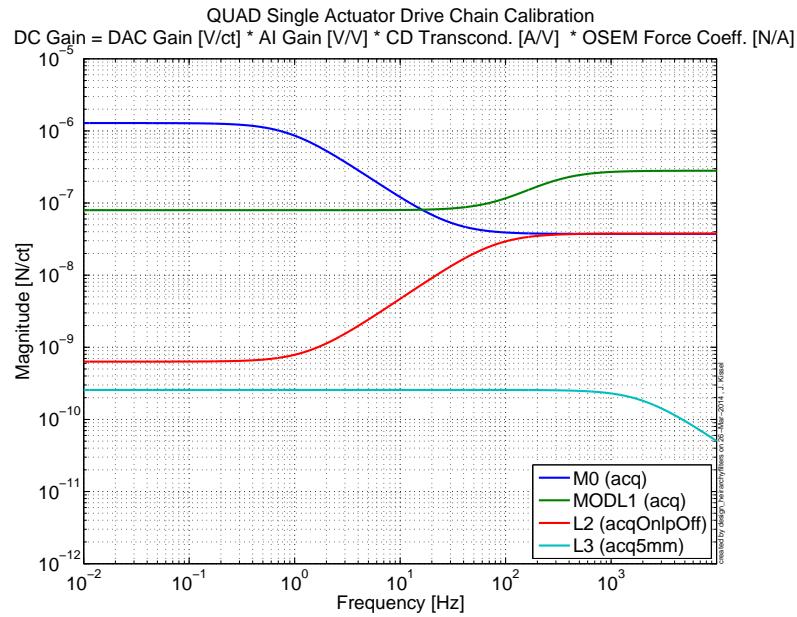
### 4.1 ITM, High-Range Configuration



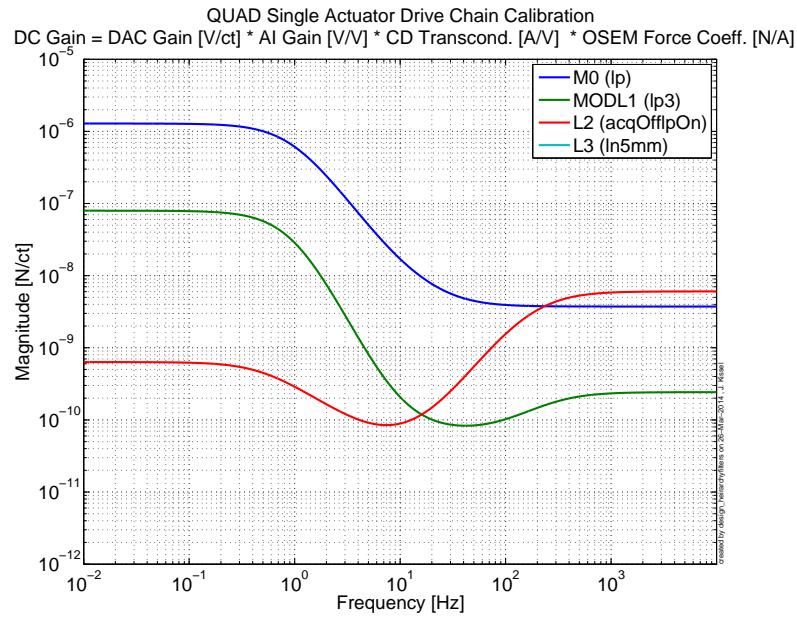
### 4.2 ITM, Low-Noise Configuration



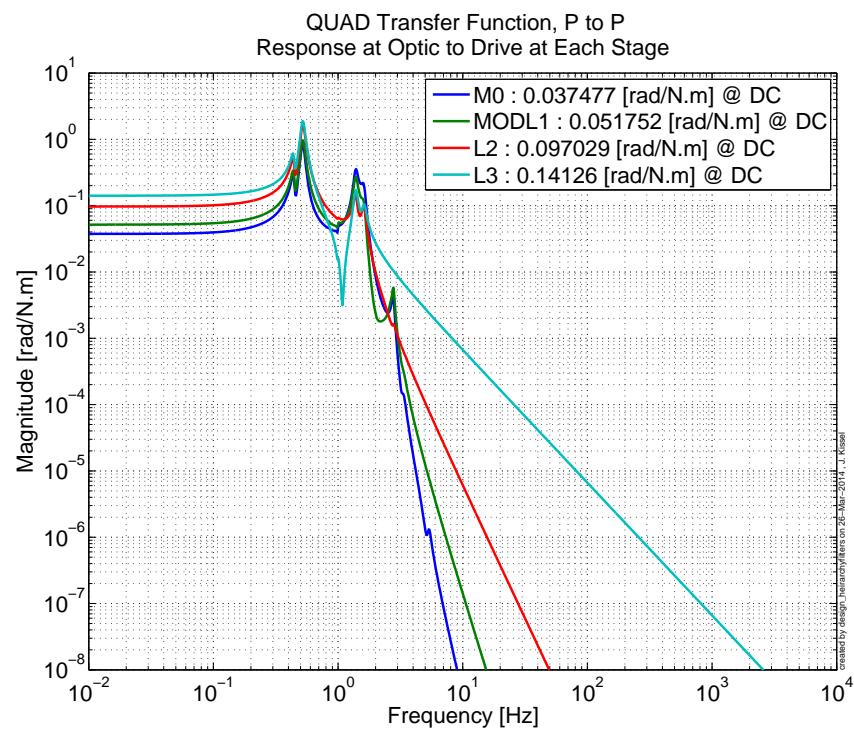
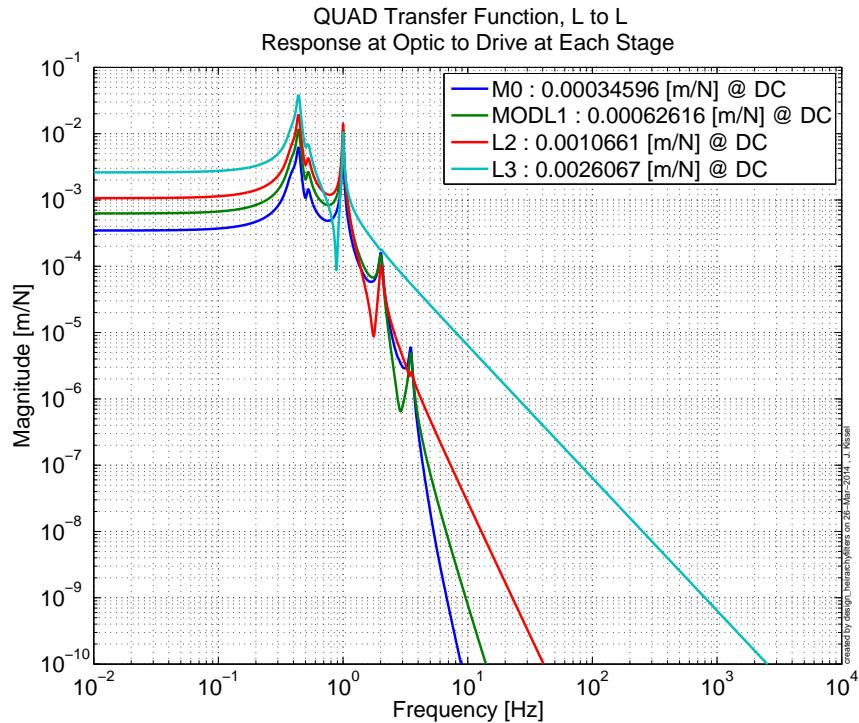
### 4.3 ETM, High-Range Configuration

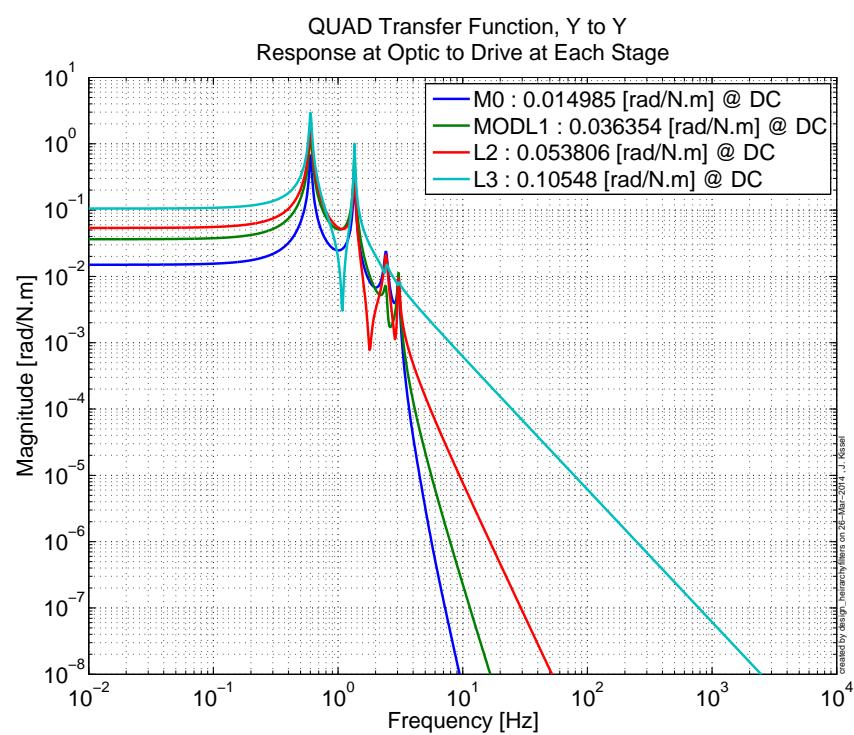


### 4.4 ETM, Low-Noise Configuration



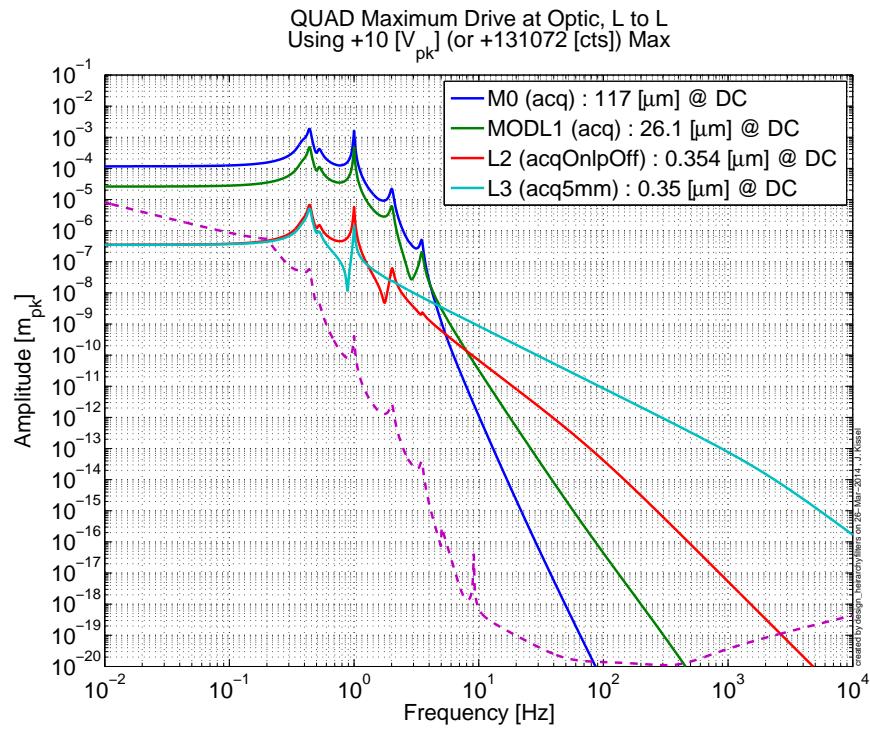
## 5 Mechanical Transfer Functions

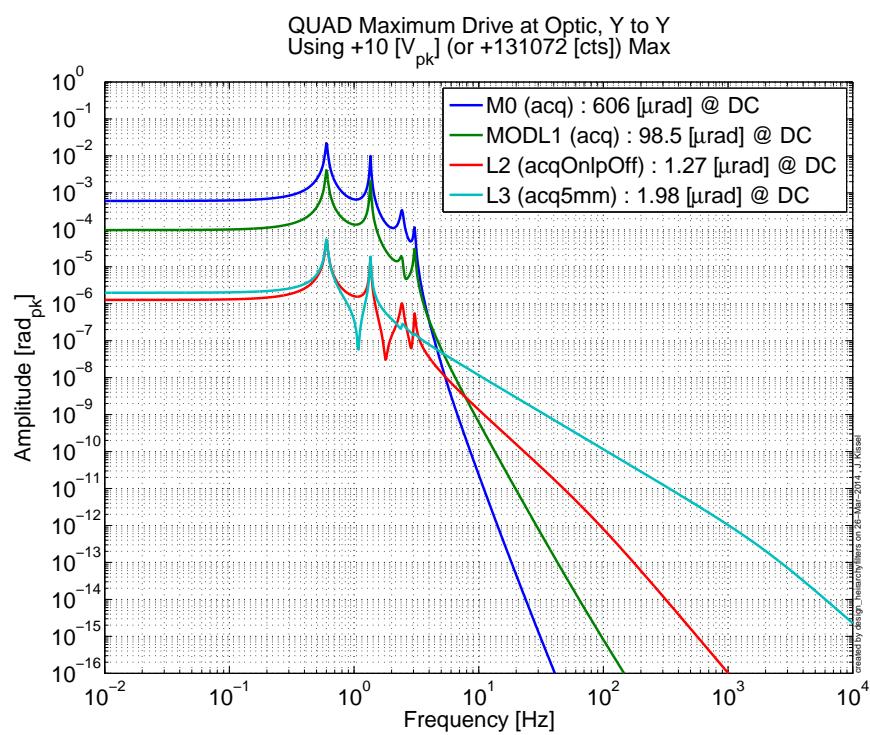
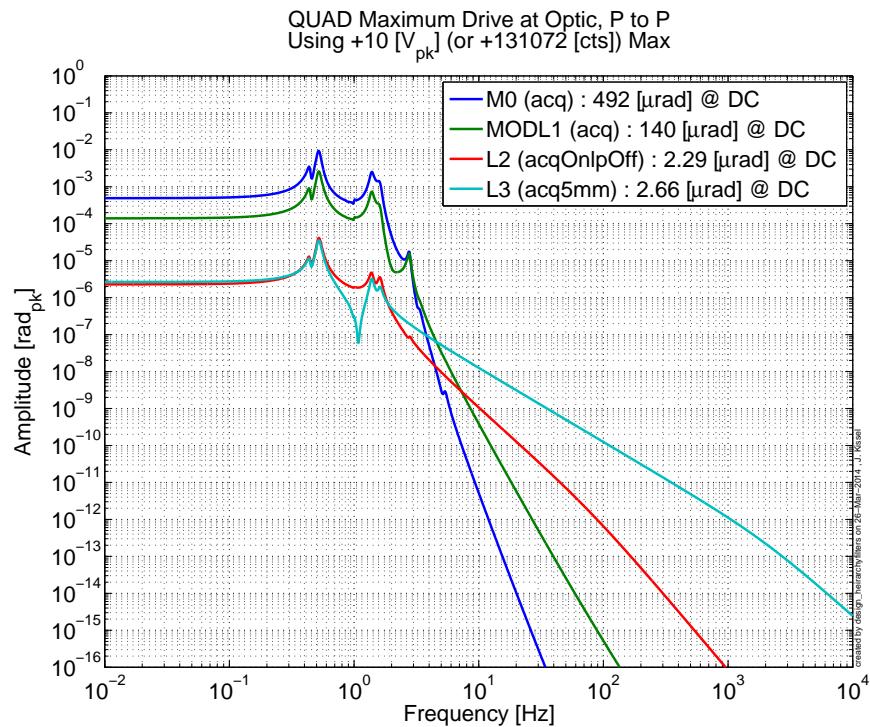




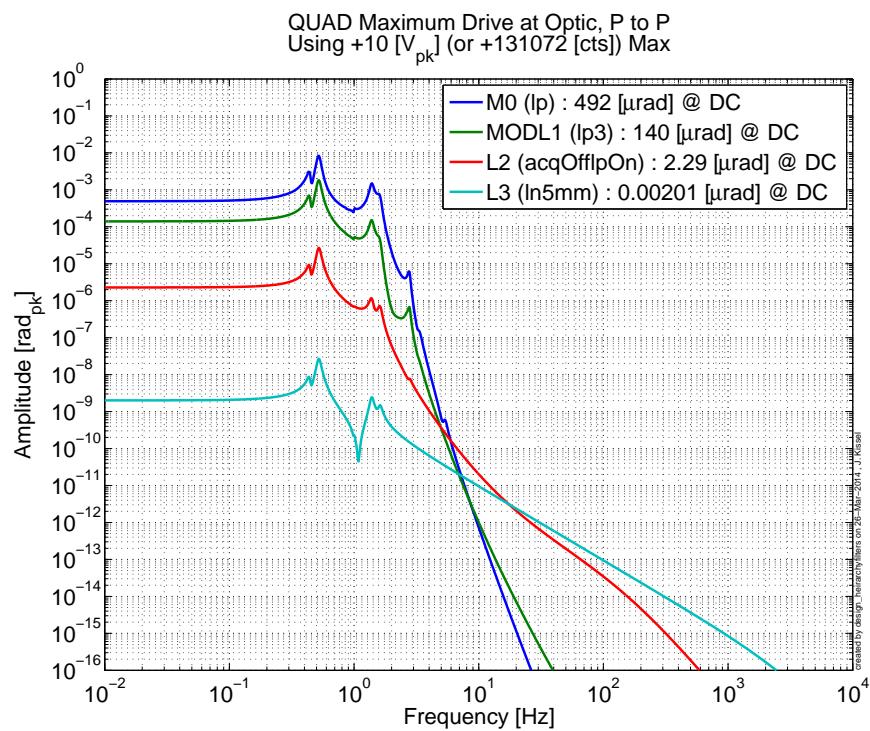
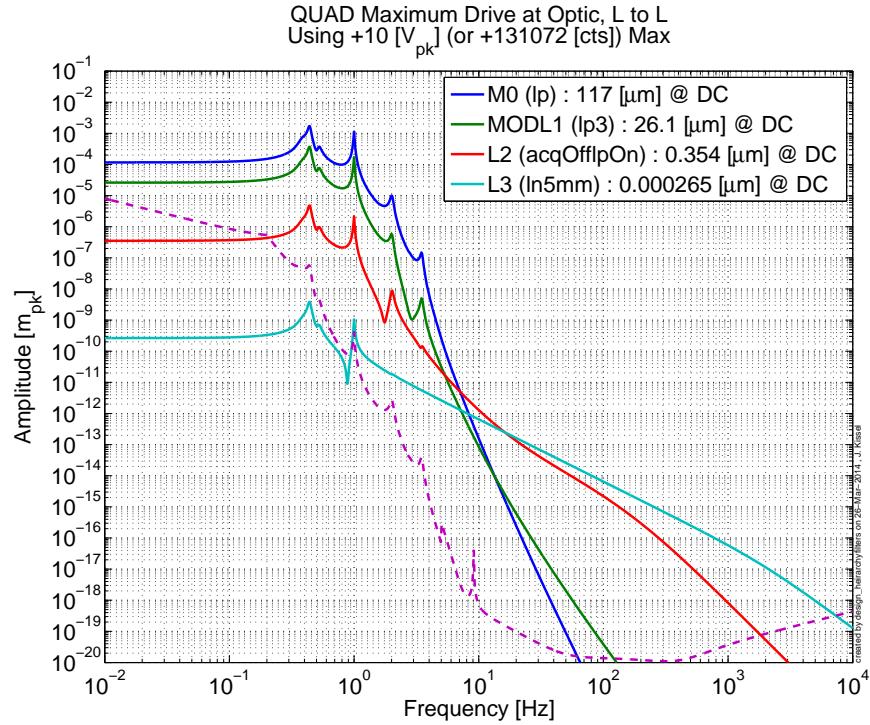
## 6 Frequency-dependent Maximum Displacement

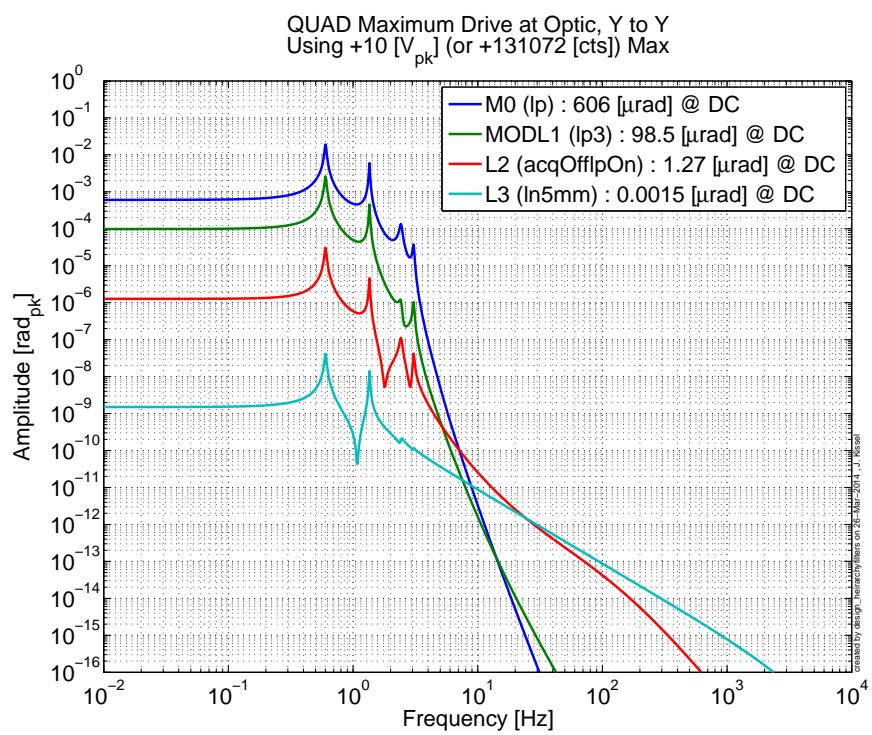
### 6.1 ETM, High-Range Configuration



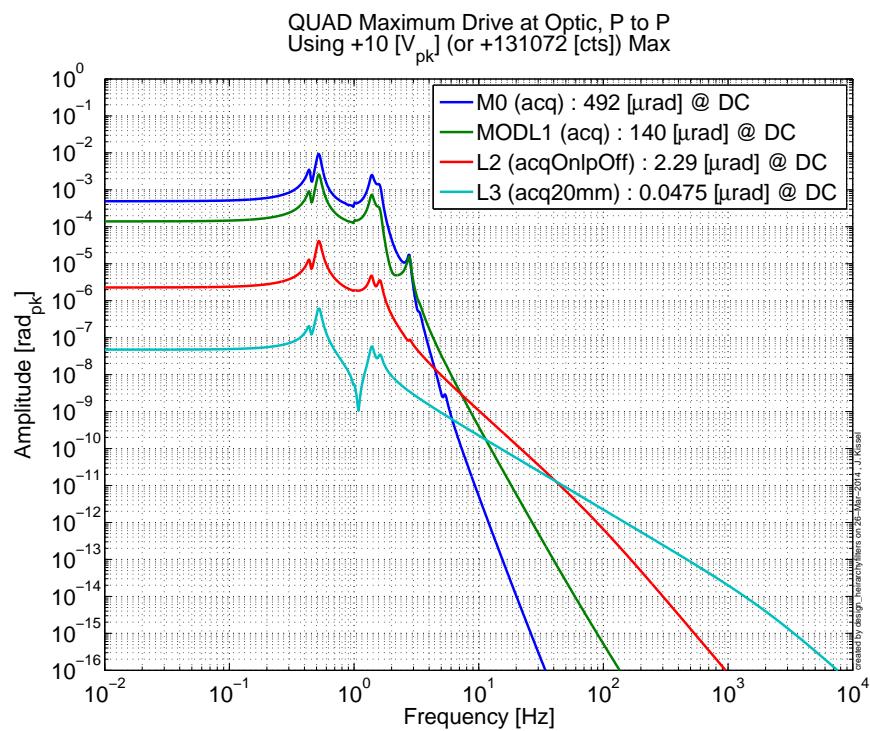
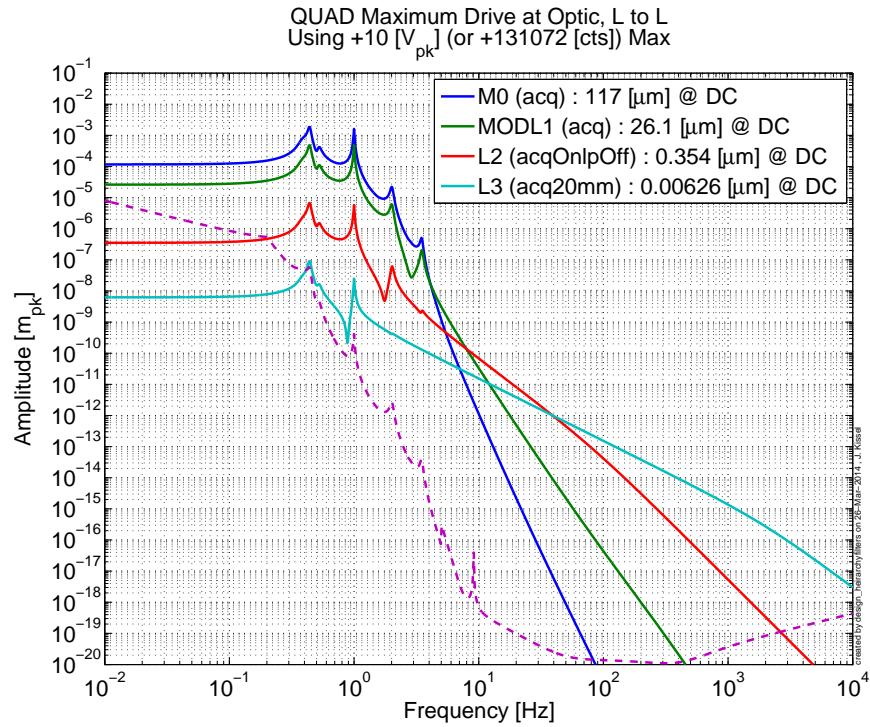


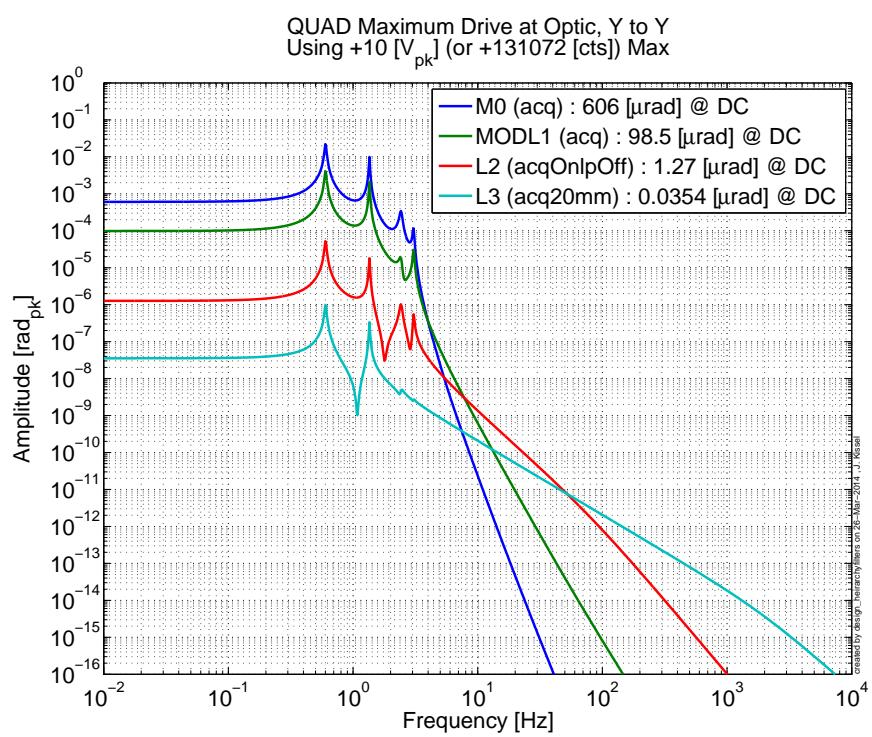
## 6.2 ETM, Low-Noise Configuration



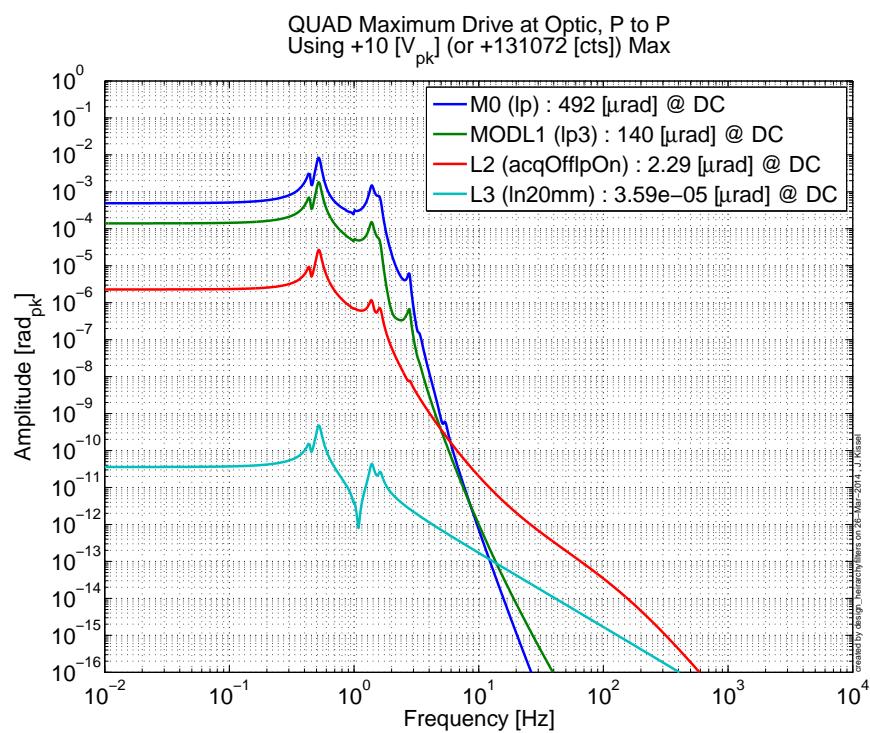
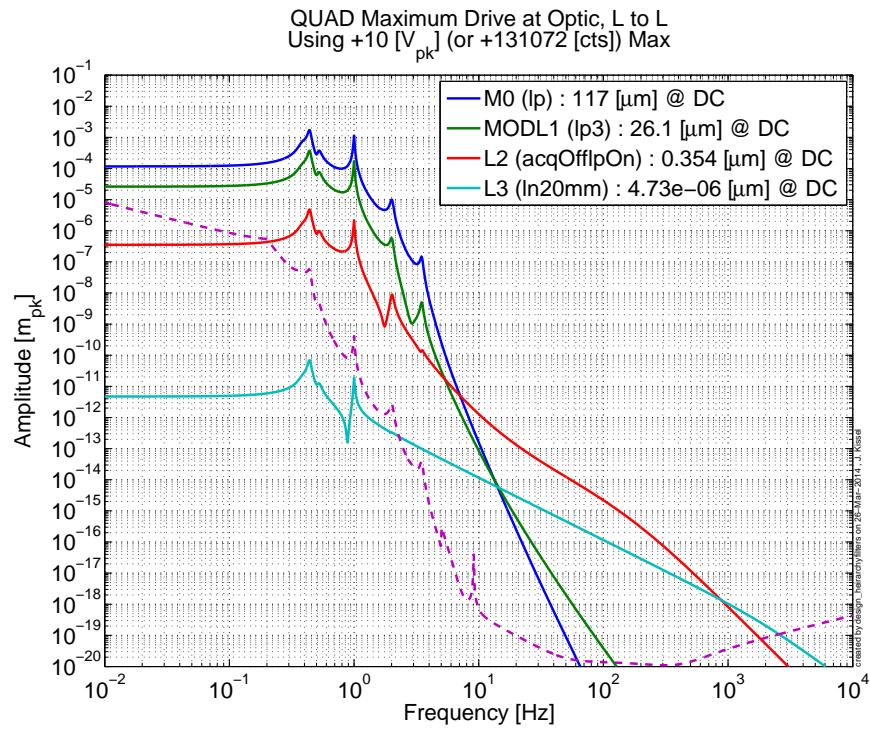


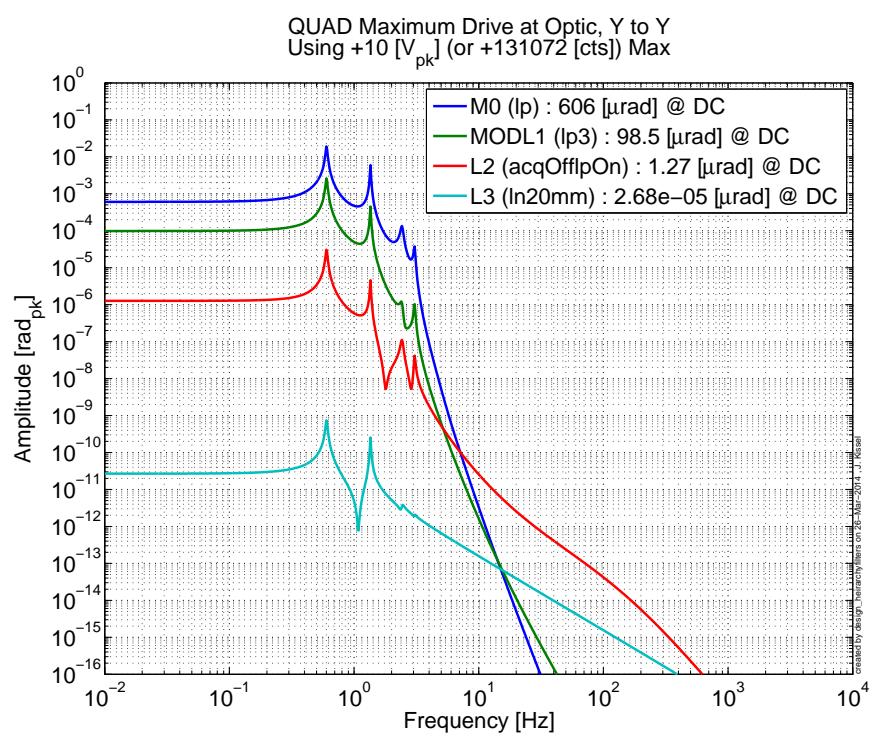
### 6.3 ITM, High-Range Configuration





## 6.4 ITM, Low-Noise Configuration





## References

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